## Inventors: HAN et al. For: "Methods of Fabricating Semiconductor Devices" Attorney Docket No. 20063/10017 Sheet 1 of 2

Fig. 1

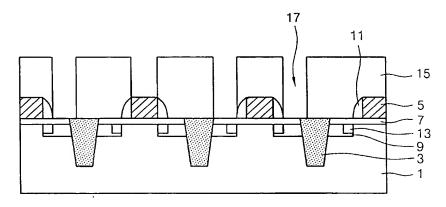


Fig. 2a

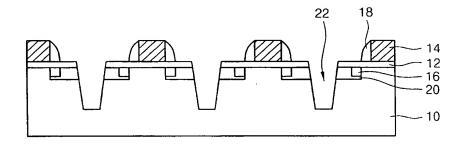
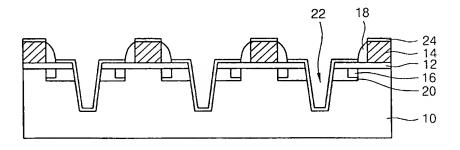


Fig. 2b



## Inventors: HAN et al. For: "Methods of Fabricating Semiconductor Devices" Attorney Docket No. 20063/10017 Sheet 2 of 2

Fig. 2c

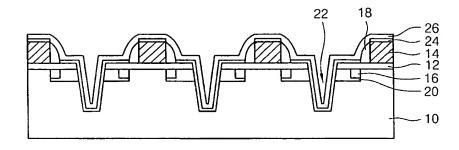


Fig. 2d

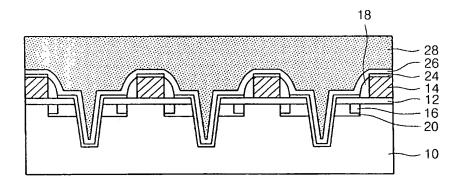


Fig. 2e

